

Applicants: Won et al. Examiner: Michael Manh Trinh  
 Serial No.: 10/723,517 Group Art Unit: 2822  
 Filed: November 26, 2003 Docket: 8028-36 (SPX200306-0004US)  
 For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

MAIL STOP AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

- Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.  
 A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.  
 No additional fee is required.

The fee has been calculated as shown below:

(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY		
CLAIMS						
REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE	OR	ADDIT. RATE
TOTAL	12*	MINUS 20**	= 0	X 25 \$ 0	X 50	\$ 0
INDEP.	2*	MINUS 3***	= 0	X 100 \$ 0	X 200	\$ 0
[ ] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM			X 180 \$	X 360 \$ 0		
TOTAL					OR TOTAL	\$ 0
<u>ADDIT. FEE</u> <u>\$ 0</u>						

\* If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

\*\* If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

\*\*\* If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The "Highest No. Previously Paid For" (TOTAL or INDEP.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_. Two (2) copies of this sheet are enclosed.
- Please charge fee of \$ \_\_\_\_ for \_\_\_\_\_ by Credit Card Payment Form PTO-2038 enclosed herewith
- Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. 50-0679. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. 50-0679 therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

F. CHAU & ASSOCIATES  
 130 Woodbury Rd  
 Woodbury, NY 11797  
 Tel: (516) 692-8888  
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Respectfully submitted,

  
 Frank Chau  
 Reg. No. 34,136  
 Attorney for Applicant

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-4150 on November 10, 2005.

Dated: November 10, 2005




**RESPONSE UNDER 37 CFR 1.116  
-EXPEDITED PROCEDURE-  
EXAMINING GROUP ART UNIT 2822**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Won et al.

Examiner: Michael Manh Trinh

Serial No.: 10/723,517

Group Art Unit: 2822

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PROCESS**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. §1.116**

Sir:

In response to the Final Office Action dated September 12, 2005, please reconsider the above-identified application in light of the following claim amendments and remarks.

**CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on November 10, 2005.

Dated: November 10, 2005

  
Frank Chau